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INFORMATION DISCLOSURE	Filing Date	March 31, 2005	
STATEMENT BY APPLICANT	First Named Inventor	"Tetsuhiro IIDA et al.	
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Sheet 1 of 1	Attorney Docket Number	1110/98318	

	U.S. PATENT DOCUMENTS					
Examin Cite er No.1 Initials*		Document Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	
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10.	Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	MM-DD-YYYY	Applicant of Cited Document	Lines, Where Relevant Passages or Relevant Figures Appear	Ţ6
1	JP 2001-270797	10-02-2001	WACKER NSCE CORP		
2	JP 2001-039792	02-13-2001	MITSUBISHI MATERIALS SILICON CORP		
3	JP 09-263484	10-07-1997	SUMITOMO SITIX CORP		
4	JP 02-217388	08-30-1990	OSAKA TITANIUM LO LTD, KYUSHU ELECTRON METAL CO LTD.		
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